

Appl. No. 10/046,594  
Amdt. dated September 26, 2008  
Reply to Office action of March 26, 2008

Appl. No.	:	10/046,594
Applicant	:	Stephen Y. Chou
Filed	:	October 29, 2001
Title	:	IMPROVED RELEASE SURFACES, PARTICULARLY FOR USE IN NANOIMPRINT LITHOGRAPHY
TC/A.U.	:	1732
Examiner	:	M. Vargot
Docket No.	:	UNMN 9372D1

Mail Stop **AMENDMENT**  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

In response to the Office Action of March 26, 2008, along with payment of all extension of time fees, please enter the following:

**Amendment of the Claims** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 15 of this paper.

I hereby certify that this correspondence is being deposited via EFS-Web with the United States Patent and Trademark Office on September 26, 2008.

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